Tool ID: 505 Tool Location: 122

#### **Equipment Information Sheet**

## **JEOL 9500**

Manager: Roberto Panepucci 607-254-4855 Calls to staff phones will be automatically forwarded to Backup: Giovanni Sartorello 607-254-4853

their cell phones during accessible hours. At other times

leave a message or send them an email.

Backup: John Treichler 607-254-4949

Backup: Xinwei Wu 607-254-4934

### **SAFETY**

No safety concerns during normal operation

## **USAGE RESTRICTIONS**

No buddy system restrictions imposed on normal operation.

Please review electron beam lithography training materials, in AFS, at shares - public processes\_from\_cnf\_staff - ElectronBeamLithography - TrainingMaterials (accessible on any general use PC or CNF Thin client at CNF)

### SCHEDULING/SIGN-UP RESTRICTIONS

Minimum Tool Time: 30 minutes

- Please put the beam current you plan to use in the Process field in Coral when you make the reservation.
- No more than 3 hour reservation between the hours of 8am 8pm, Monday through Friday.
- Maximum 12 hours reserved in advance at any time per person.
- The same user, group, or company must have at least 3 hours between any 2 reservations.

#### MATERIALS COMPATIBILITY CATEGORY

# Tool Category 5: Class A and B Metals and Compounds Allowed **Not Allowed** Tool category 1/1E, 2, 3, and 4 materials Silicon Based Substrates and Films III/V compound Semiconductors Glass Substrates PECVD and ALD Films Cured organics and baked Photoresist CNF Class A, B, and Refractory metals Exposed Gold, Silver, Copper Alkali and Alkaline Compounds Organic/Biology Molecules preparedw/salt buffers High Vapor Pressure Materials (Mg, Ca, \* Some tool restrictions on high vapor pressure Zn)\*materials may apply Soft organic materials

High Vapor Pressure Metals and Compounds are materials that have a vapor pressure above 1e-6 Torr at 400 C.

## **Additional Material Restrictions and Exceptions**

• Fully baked resists only; do not load samples with unbaked resist or glue or anything that may degas.

• Please review electron beam lithography training materials, in AFS, at shares - public - processes\_from\_cnf\_staff - ElectronBeamLithography - TrainingMaterials (accessible on any general use PC or CNF Thin client at CNF)

Last Updated: 04/15/2025